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Attorney Docket No.: PATENT
SSI-04001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of:

William D. Jones

Serial No.: 10/680,783

Filed: October 6, 2003

For: **HIGH-PRESSURE PROCESSING
CHAMBER FOR A
SEMICONDUCTOR WAFER**

) Group Art Unit: 1763

) Examiner: Jeffrie R. Lund

) **TRANSMITTAL LETTER**

) 162 N. Wolfe Road
) Sunnyvale, CA 94086
) (408) 530-9700

) Customer No. 28960

MS: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Enclosed please find a Supplemental Information Disclosure Statement, a Certification pursuant to 37 C.F.R. § 1.97(e) for the Supplemental Information Disclosure Statement, and Form PTO-1449, including copies of the references contained thereon, for filing in the U.S. Patent and Trademark Office.

The Commissioner is hereby authorized to charge any additional fee or credit overpayment to our Deposit Account No. 08-1275. **An originally executed duplicate of this transmittal is enclosed for this purpose.**

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 4-18-06

By: *Thomas B. Haverstock*
Thomas B. Haverstock
Reg. No.: 32,571

Attorneys for Applicant

CERTIFICATE OF MAILING (37 CFR § 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

HAVERSTOCK & OWENS LLP.
Date: 4/18/06 By: *File*



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) **CERTIFICATION FOR**
) **SUPPLEMENTAL INFORMATION**
) **DISCLOSURE STATEMENT UNDER 37**
) **CFR § 1.97(e)**

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Alexandria, VA 22313-1450

Sir:

This certification is being made for the Supplemental Information Disclosure Statement accompanying this certification.

Certification

I hereby certify that the attached seven (7) references contained in this supplemental information disclosure statement were cited within an official action from a foreign patent office mailed on January 31, 2006. **Accordingly, the references contained in the supplemental information disclosure statement were cited in a communication from a foreign patent office in a counterpart application not more than three months prior to the filing of the statement. 37 C.F.R. 1.97(e)(1).**

Identification of Person Making Certification

The person making this certification is the attorney who signs below on the basis of the information in the attorney's file.

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 4-18-06

By: Thomas B. Haverstock
Thomas B. Haverstock
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- 2 -

HAVERSTOCK & OWENS LLP.
Date: 4/18/06 By: [Signature]



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Alexandria, VA 22313-1450

Sir:

The citations listed below, copies attached, may be material to the examination of the above-identified application, and are therefore submitted in compliance with the duty of disclosure defined in 37 C.F.R. §§ 1.56 and 1.97. The Examiner is requested to make these citations of official record in this application.

Applicant has become aware of the following printed publications which may be material to the examination of this application:

- European Publication No. EP 0 726 099 A2;
- Japanese Patent No. JP 4-17333;
- Japanese Patent No. JP 8-252549;
- Japanese Patent No. JP 9-43857;
- Japanese Patent No. JP 10-260537;
- Japanese Patent No. JP 11-274132; and
- Japanese Patent No. JP 63-179530.

This Supplemental Information Disclosure Statement under 37 C.F.R. §§ 1.56 and 1.97 is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that anyone or more of these citations constitutes prior art.

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 4-18-06

By: Thomas B. Haverstock
Thomas B. Haverstock
Reg. No.: 32,571

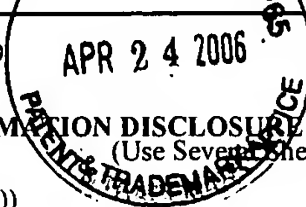
Attorneys for Applicant

CERTIFICATE OF MAILING (37 CFR § 1.8(a))

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HAVERSTOCK & OWENS LLP.
Date: 4/18/06 By: [Signature]

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| FORM PTO-1449 (Modified) | |  | | U.S. Department of Commerce Patent and Trademark Office | | Attorney Docket No.: SSI-04001 | | Serial No.: 10/680,783 | |
| INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use Several Sheets If Necessary) | | | | | | Applicant: William Dale Jones | | | |
| (37 CFR § 1.98(b)) | | | | | | Filing Date: October 6, 2003 | | Group Art Unit: 1763 | |
| U.S. PATENT DOCUMENTS | | | | | | | | | |
| Examiner Initials | | Serial / Patent Number | Issue Date | Applicant / Patentee | Class | Subclass | Filing Date | | |
| | AA | | | | | | | | |
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| FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS | | | | | | | | | |
| | | Document Number | Publication Date | Country / Patent Office | Class | Subclass | Translation | | |
| | | | | | | | Yes | No | |
| | AK | EP 0 726 099 A2 | 08/14/96 | EPO | B08B | 5/00 | | X | |
| | AL | JP 4-17333 | 01/22/92 | JPO | H01L | 21/304 | | X | |
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| OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication) | | | | | | | | | |
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| EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | | | | | | | | | |